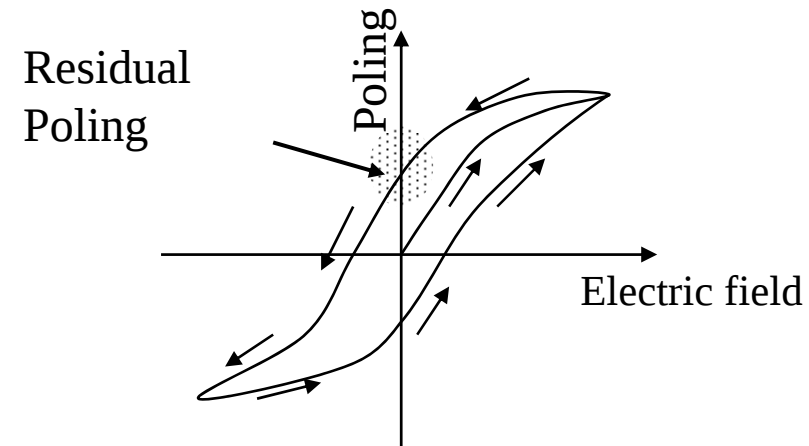
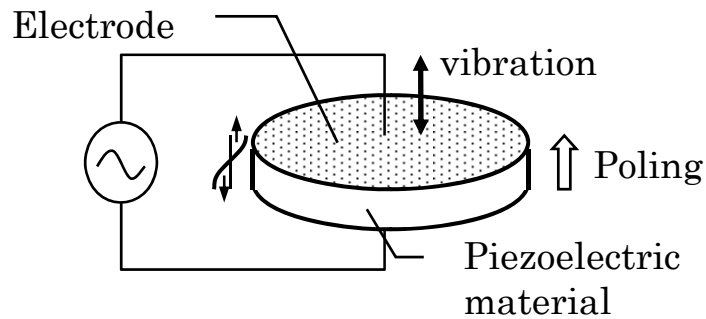


圧電振動子の基礎 Basics for piezoelectricity



- 両面固定、電界 E を印加 Fixed and electric field E : 応力 stress, $T = e E$
- 両端短絡、ひずみ S を発生 Short circuited, strain S : 電束密度 Flux density, $D = e S$
- 両端開放、応力 T を印加 Open circuited, stress T : 電界 electric field, $E = g T$

圧電方程式

$$\begin{cases} [T] = [c^E][S] - [e_t][E] \\ [D] = [e][S] + [\varepsilon^S][E] \end{cases}$$

Piezoelectric
equations

$$\begin{cases} [S] = [s^E][T] + [d_t][E] \\ [D] = [d][T] + [\varepsilon^T][E] \end{cases}$$

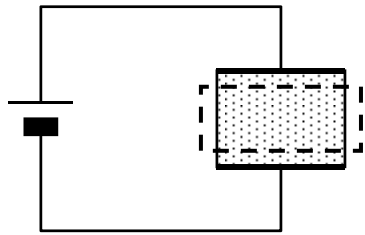
$$\begin{cases} \text{弾性定数 Elastic const. } c, s \\ \text{圧電定数 Piezoelectric const. } d, e \\ \text{誘電率 Permittivity } \varepsilon \end{cases}$$

電気機械結合係数(静的) k^2

Electro-mechanical coupling factor (static)

$$k^2 = \frac{\text{Mechanically stored energy}}{\text{Electrically stored energy}}$$

Electro-mechanical coupling factor as the material constant.



Mechanical

$$\frac{1}{2} S \cdot T = \frac{1}{2} S \cdot \frac{S}{c} = \frac{1}{2} (d \cdot E)^2 / c$$

Electrical

$$\frac{1}{2} \varepsilon \cdot E^2$$

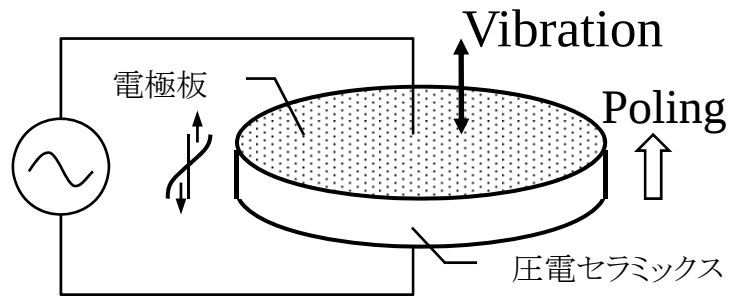
Per unit volume

Coupling factor

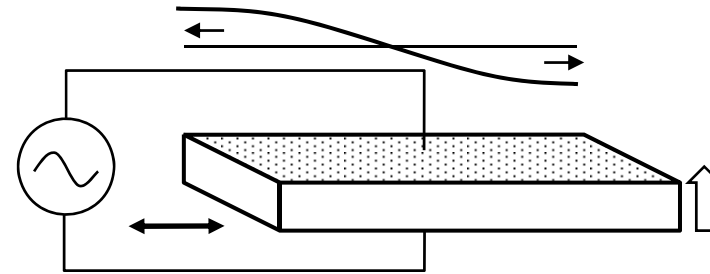
$$k^2 = \frac{d^2}{\varepsilon S}$$

基本的な圧電振動子

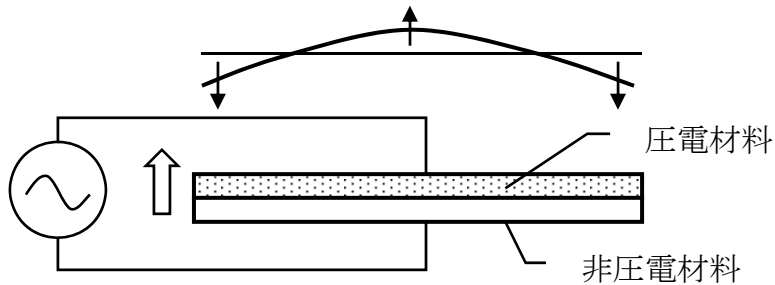
Typical piezoelectric transducers



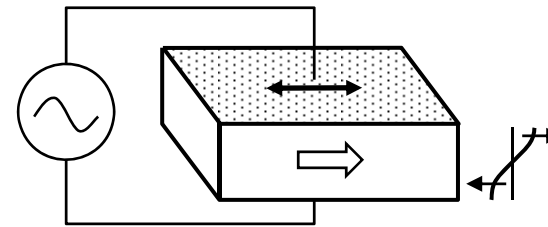
Thickness mode with longitudinal effect



Axial vibration with transverse effect



Bending mode with a mono-morph



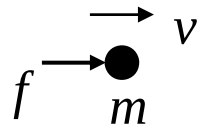
Shear mode

Electrical equivalent circuit (1)

Analogy between the mechanical and electrical systems

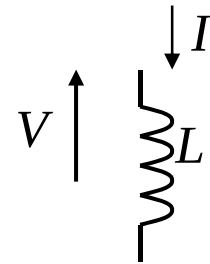
1) Mass=Inductor

Force $\rightarrow$ Voltage, Velocity $\rightarrow$ Current



A diagram showing a mass m represented by a black dot. A horizontal arrow labeled f points to the right, and another horizontal arrow labeled v points to the right above the dot.

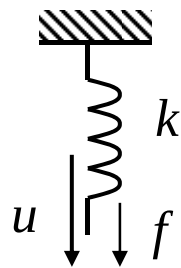
$$f = m \frac{dv}{dt}$$



A diagram of an inductor symbol (a zigzag line). A vertical arrow labeled V points upwards to the left of the symbol. A vertical arrow labeled I points downwards to the right of the symbol.

$$V = L \frac{dI}{dt}$$

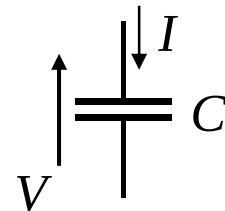
2) Spring=Capacitor



A diagram of a spring. The top is fixed to a hatched horizontal bar. The spring is represented by a zigzag line. A vertical arrow labeled u points downwards to the left of the spring. A vertical arrow labeled f points downwards to the right of the spring.

$$f = \frac{1}{c_m} u = \frac{1}{c_m} \int v dt$$

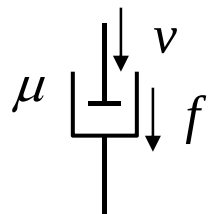
$$c_m = 1/k$$



A diagram of a capacitor symbol (two parallel horizontal lines). A vertical arrow labeled V points upwards to the left of the symbol. A vertical arrow labeled I points downwards to the right of the symbol.

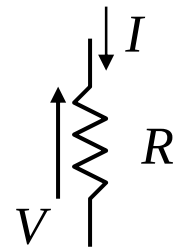
$$V = \frac{1}{c} \int I dt$$

3) Damper=Resistor



A diagram of a damper symbol (a rectangle with a diagonal line). A vertical arrow labeled v points downwards to the right of the symbol. A vertical arrow labeled f points downwards to the right of the symbol.

$$f = \mu v$$



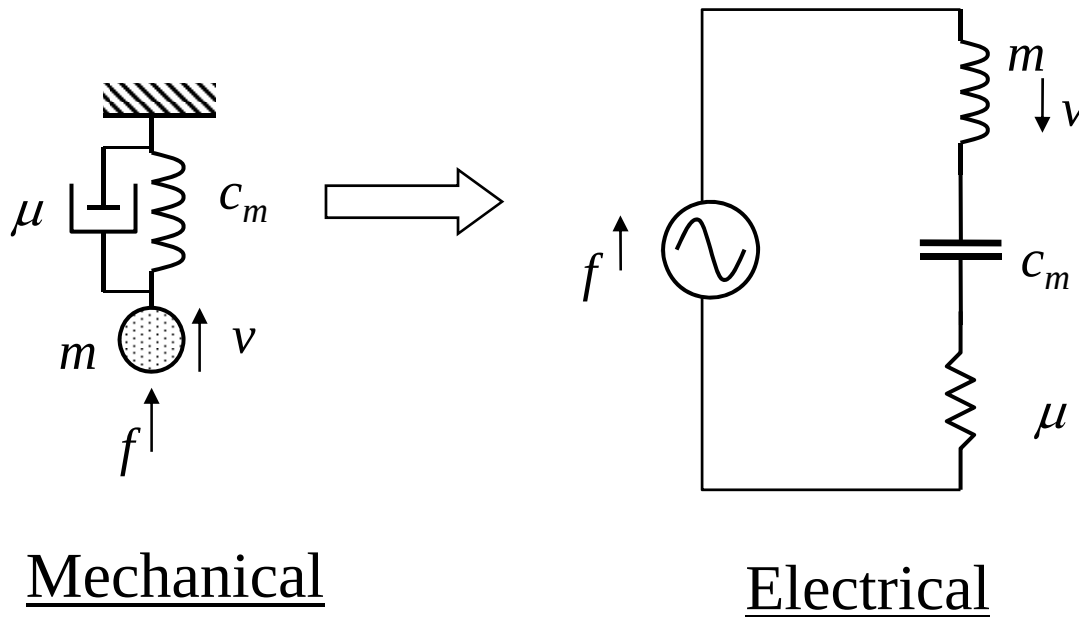
A diagram of a resistor symbol (a zigzag line). A vertical arrow labeled V points upwards to the left of the symbol. A vertical arrow labeled I points downwards to the right of the symbol.

$$V = R I$$

Electrical equivalent circuit (2)

Harmonic oscillator with a mass and a spring

→ LCR resonance

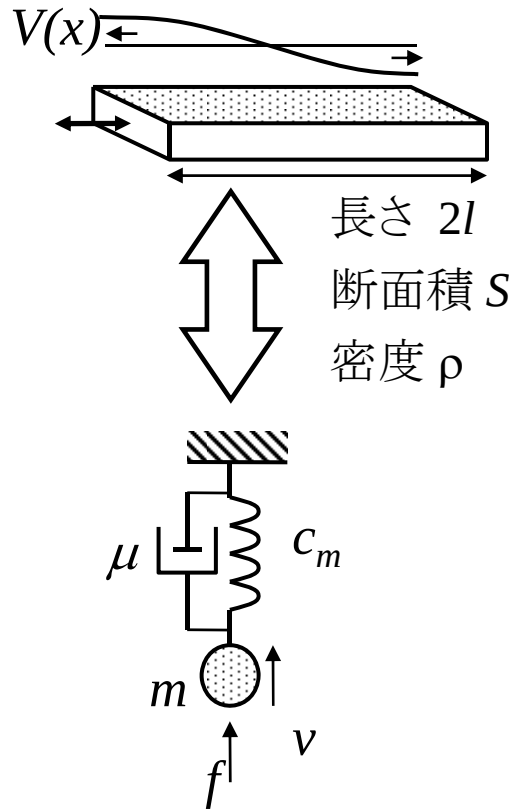


Variable common among the circuit components?

→ Velocity v

Electrical equivalent circuit (3)

Transducer=distributed circuit $\Longrightarrow$ Lumped circuit



Determine m so that the kinetic energies in the actual transducer and the equivalent circuit be the same.

Total mass $M = 2L\rho S$

Resonance $\omega = \frac{\pi}{2L} \sqrt{\frac{E}{\rho}}$

Kinetic energy by the longitudinal vibration in the plate

$$U_D = \int_{-L}^L \frac{1}{2} \rho S v^2(x) dx$$

Kinetic energy in the lumped model

$$U_L = \frac{1}{2} m v^2(0)$$

Equivalent mass

$$m = M / 2$$

Electrical equivalent circuit (4)

弾性エネルギーについても同様にして c_m を決定

c_m can be found through the same procedure,
considering the elastic energy

* 共振周波数から求めても良い。

Alternatively, it can be found from the resonance
frequency and the mass.

$$\frac{1}{c_m} = \frac{\pi^2}{4} \frac{ES}{L}$$

等価スティッフネス

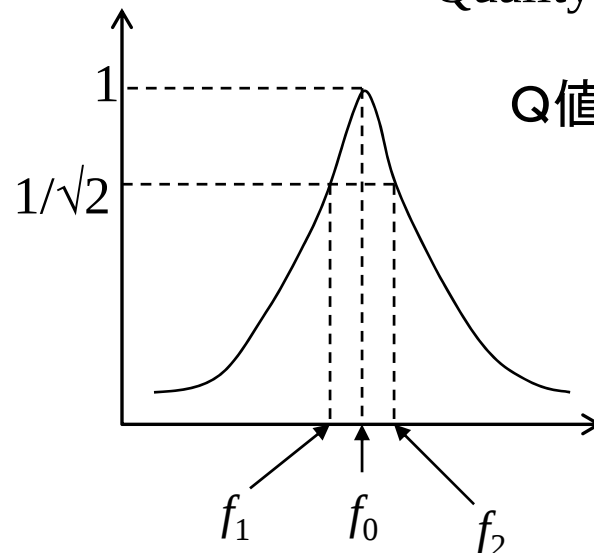
Equivalent stiffness

損失項 Loss μ

機械的Q

Quality factor

$$Q_m = \frac{\omega m}{\mu}$$



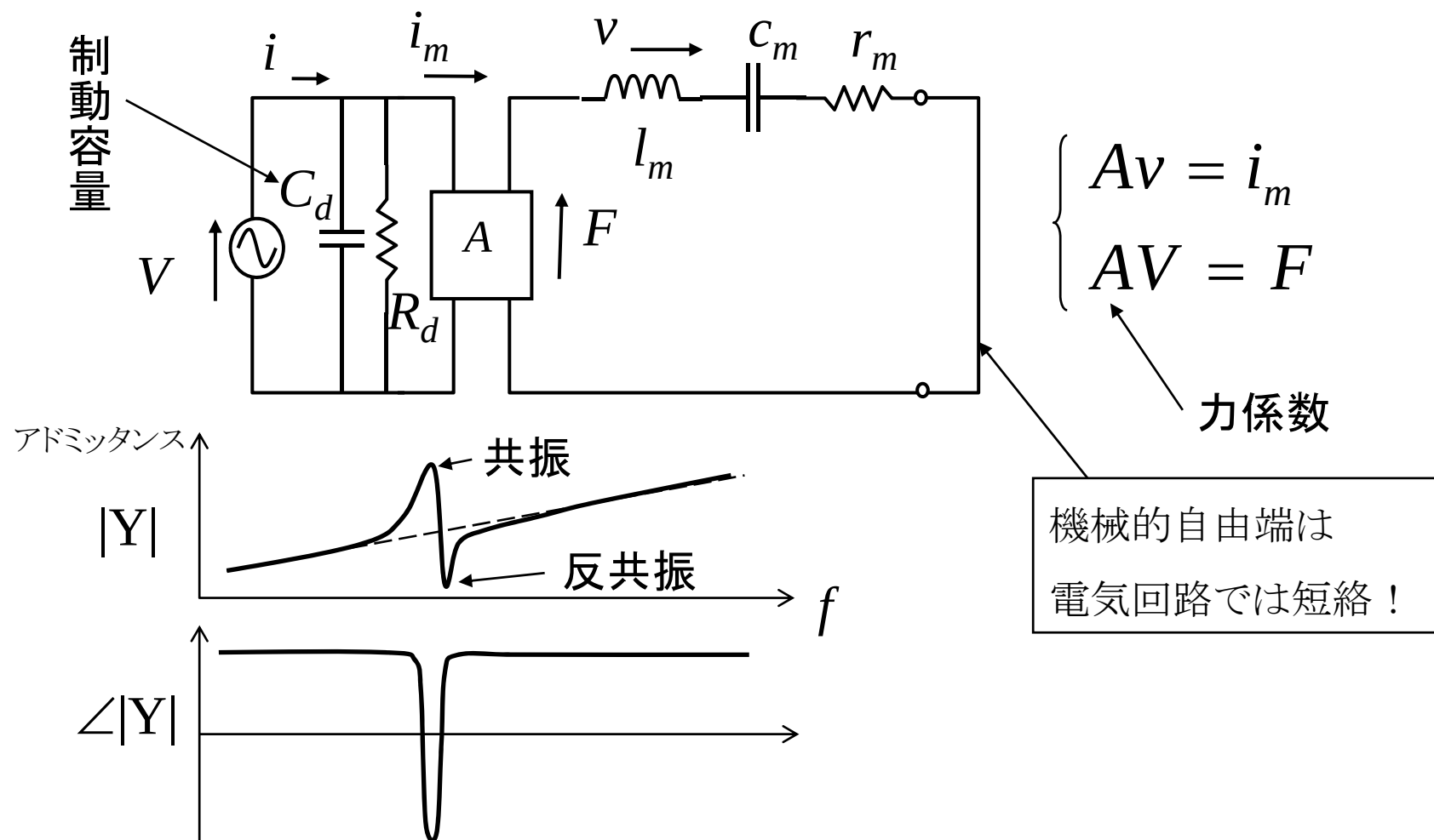
Q値の測定 measurement of Q

$$Q_m = \frac{f_0}{f_2 - f_1} \quad (Q_m > 10)$$

圧電振動子の等価回路(圧電性の導入)

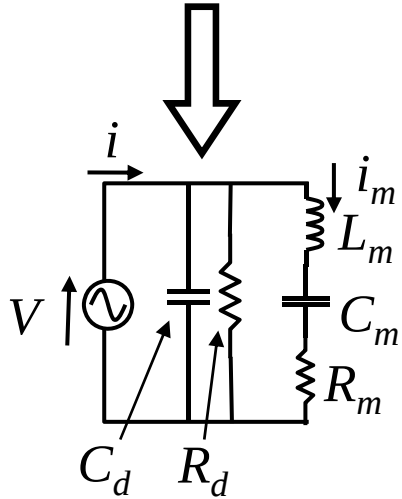
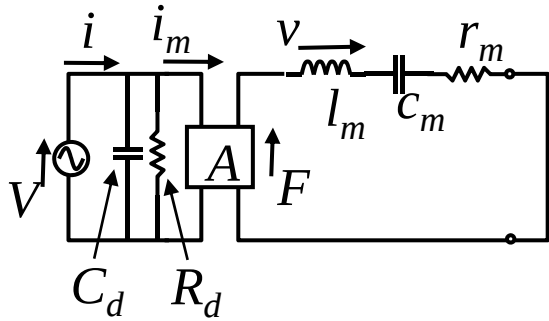
強誘電体=キャパシタ(静電エネルギー)
機械変形=ばね(弾性エネルギー)

変形量 $\propto$ 流れ込んだ電荷量 $\therefore$ 速度 $\propto$ 電流, 力 $\propto$ 電圧



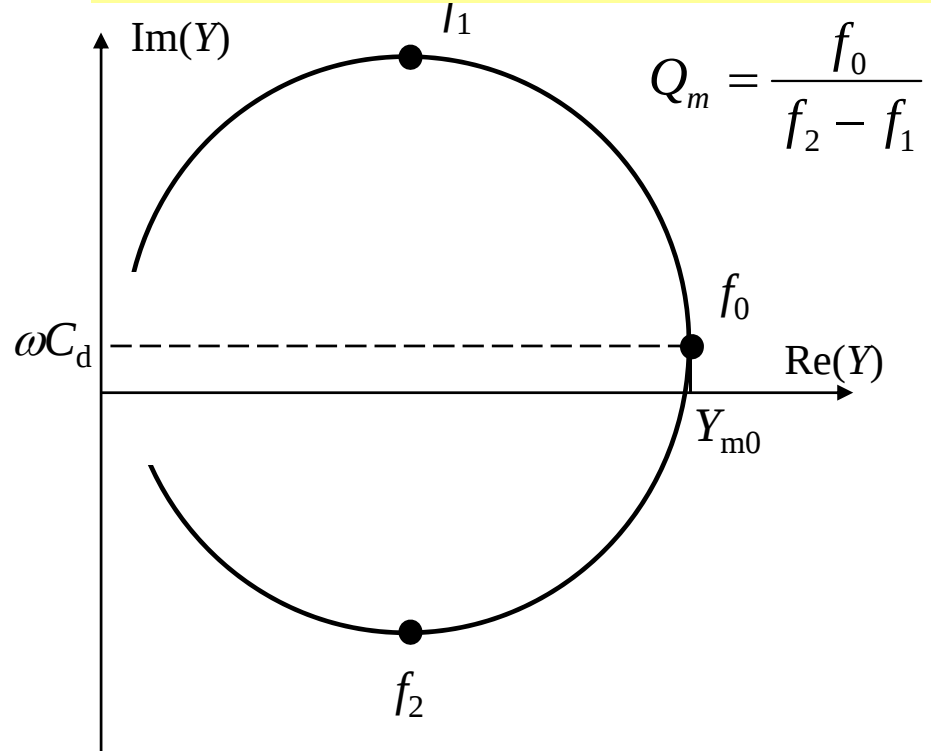
圧電振動子の電気端子から見た特性

Electrical characteristics



$$\left\{ \begin{array}{l} R_m = r_m / A^2 \\ L_m = l_m / A^2 \\ C_m = A^2 c_m \end{array} \right.$$

アドミッタンスループ Admittance loop



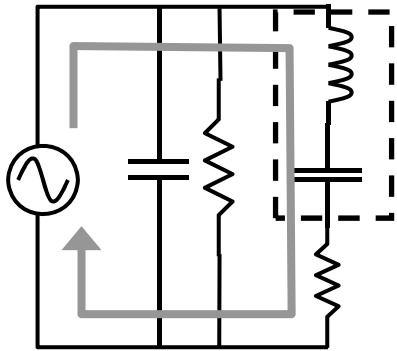
$$R_m = \frac{1}{Y_{m0}}$$

$$L_m = \frac{Q_m R_m}{2\pi f_0}, \quad C_m = \frac{1}{2\pi f_0 Q_m R_m}$$

共振と反共振 Resonance and anti-resonance

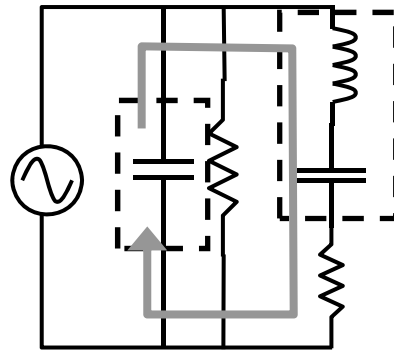
{ 共振 = インピーダンス小
 反共振 = インピーダンス大

Resonance
共振状態



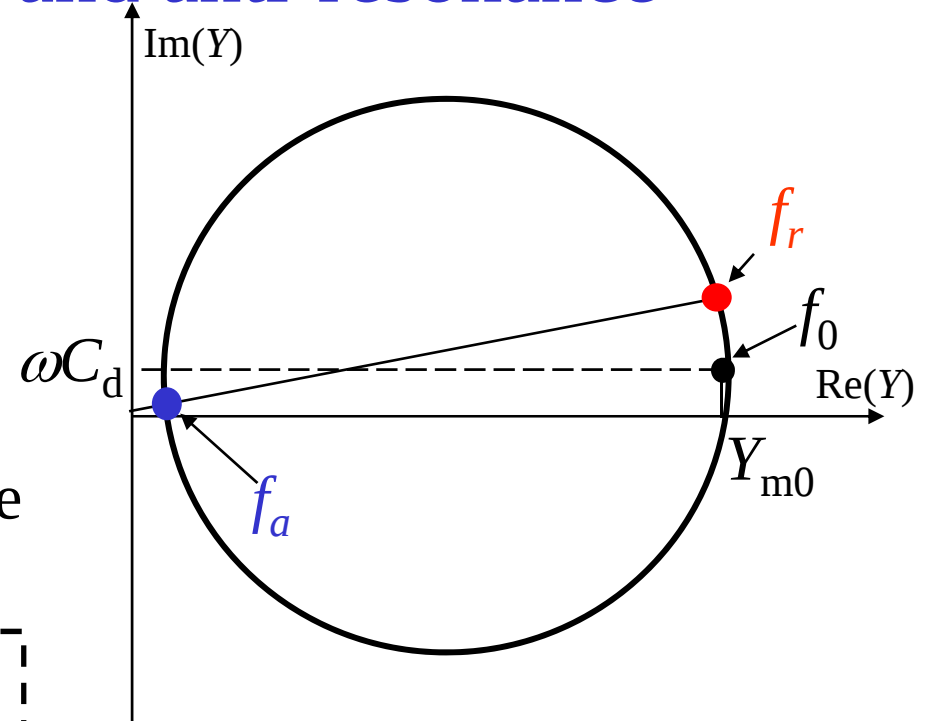
f_r

Anti-resonance
反共振状態



f_a

<



共振 f_r

Y_m の大きさ最大

反共振 f_a

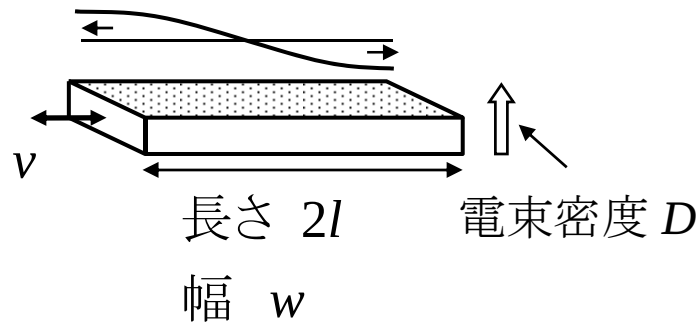
Y_m の大きさ最小

機械共振 f_0

Y_m の実部最大

力係数の計算・測定 Calculation of force factor

横効果振動子の場合



力係数 force factor $A = i / v$

$$\begin{cases} i = j\omega \int_S D dS, & D = d_{31}T \\ T(x) = E \frac{\partial u}{\partial x} = \frac{\pi E V}{j\omega \cdot 2l} \sin \frac{\pi x}{2l} \end{cases}$$

$$A = 2wEd_{31} = \frac{2wd_{31}}{s_{11}}$$

測定 Measurement of force factor

1) 電流と振動速度の実測値から (動電流を抽出する必要がある)

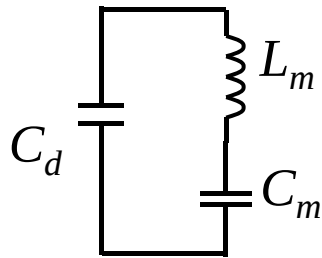
From the ratio of the current to the vibration velocity

2) 付加質量法 (微小質量を付加した場合の共振周波数変化から算出)

Form the frequency shift when a small additional mass is attached.

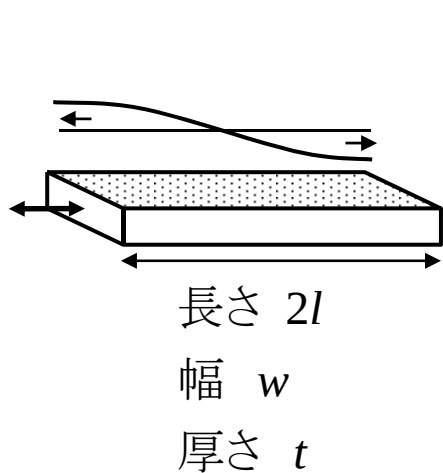
振動子としての電気機械結合係数

Electro-mechanical coupling factor as a transducer



電気エネルギー Electrical = C_d にたまる

機械エネルギー Mechanical = C_m にたまる



$$A = \frac{2wd_{31}}{s_{11}}$$

$$\frac{1}{C_m} = \frac{\pi^2}{4} \frac{wt}{s_{11}l}$$

$$C_d = \frac{\varepsilon_{33}w \cdot 2l}{t}$$

$$k_v^2 = \frac{C_m}{C_d} = \frac{A^2 C_m}{C_d} = \frac{8}{\pi^2} k_{31}^2$$

$$k_v^2 = \frac{f_a^2 - f_r^2}{f_a^2} \approx \frac{2(f_a - f_r)}{f_a}$$

共振・反共振から測定

It can be calculated from the resonance frequencies

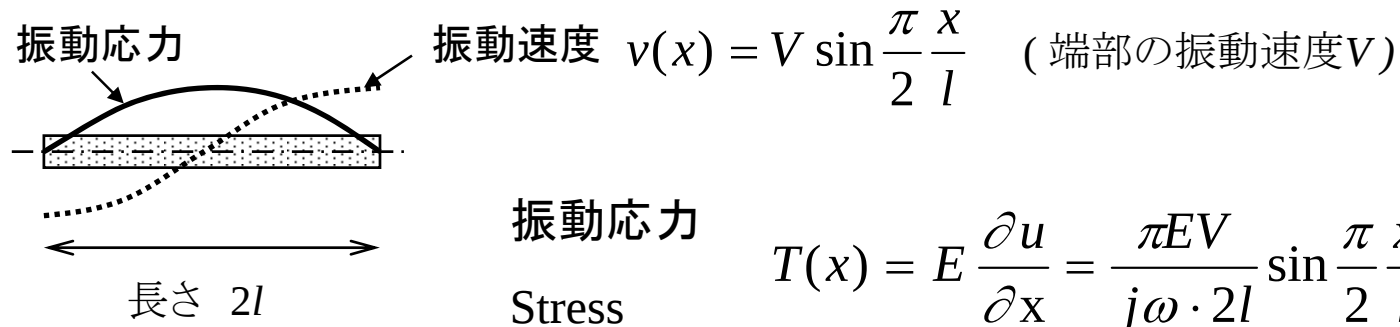
共振・反共振周波数が離れているほど電気機械結合係数が高い

Larger separation between the resonance frequencies, higher coupling factor

最大振動速度の検討 Maximum vibration velocity

振動応力による破壊 : 圧電セラミックスの疲労強度 $T_{\max}=40$ MPa程度

Fatigue limit of the piezoelectric ceramics



$\lambda/2$ 共振子

$$V_{\max} = \frac{2\omega l}{\pi E} T_{\max} = \frac{T_{\max}}{\sqrt{\rho E}}$$

最大応力を特性インピーダンスで除したもの

Question:

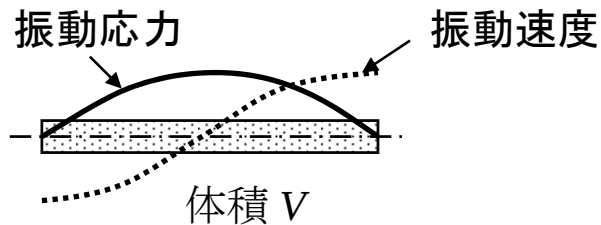
Find the maximum velocity of PZT ceramics, where the effect of temperature is ignored

$$\rho = 7900 \text{ kg / m}^3, \quad E = 66 \text{ GPa}$$

$$V_{\max} = \boxed{} \text{ m / s(0 - p)}$$

圧電振動子のパワー密度の検討

圧電セラミックスの疲労強度 $T_{\max}=40\text{MPa}$ 程度



$$v_{\max} = \frac{2\omega l}{\pi E} T_{\max} = \frac{T_{\max}}{\sqrt{\rho E}}$$

$$\rho = 7900 \text{ kg / m}^3, \quad E = 66 \text{ GPa}$$

$$v_{\max} = 1.7 \text{ m / s (0 - p)}$$

等価質量 $m=\rho V/2$ の振動子で考える

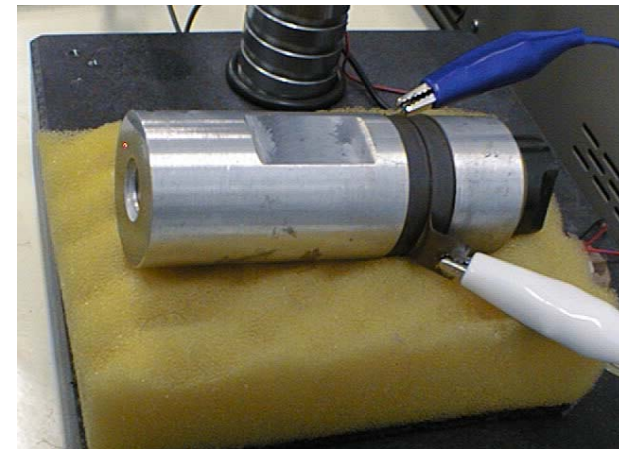
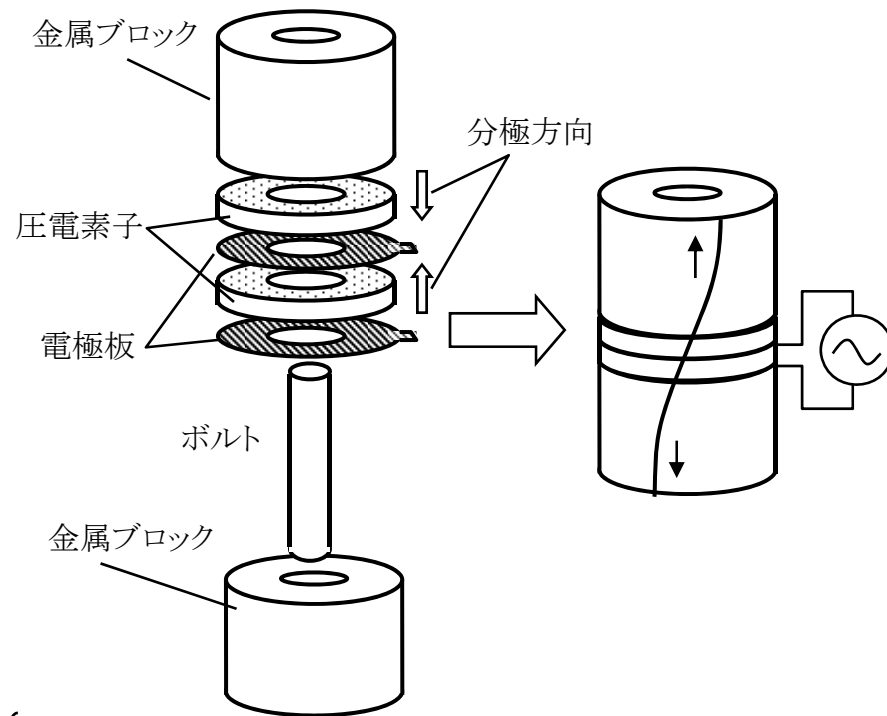
$$\text{最大運動エネルギー} \quad U_{K\max} = \frac{1}{2} m v_{\max}^2 = \frac{\rho V}{4} \frac{T_{\max}^2}{\rho E} = \frac{T_{\max}^2}{4E} V$$

$$\text{最大パワー密度} \quad P_{\max} = \frac{f \cdot U_{K\max} / 2}{V} = \frac{f \cdot T_{\max}^2}{8E} \times 10^{-6} [\text{W / cc}]$$

20kHz で 約60 W/cc

高周波化すれば高パワー密度化

ボルト締めランジュバン型振動子

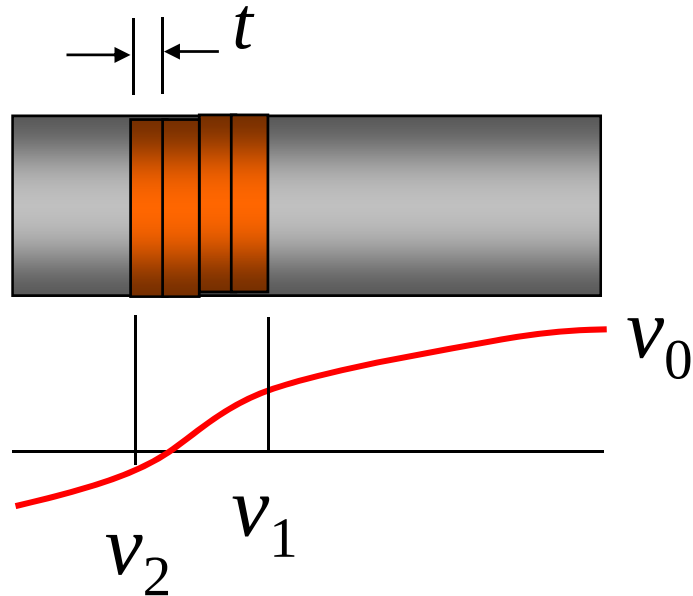


実際のボルト締め振動子

- 金属ブロックにより長さをかせぐ＝低周波化
- ボルトで締める＝予圧により強度増大

セラミックスは引っ張り強度が低い

ランジュバン振動子の力係数 $A = A_{\text{PZT}} \times \phi$



変成比 $\phi = (v_1 - v_2) / v_0$

PZT1枚の力係数 A_{PZT}

$$A_{\text{PZT}} = eS / t$$

$\left\{ \begin{array}{l} e, \text{ 圧電応力定数} \\ S, \text{ 面積} \\ t, \text{ PZT1枚の厚さ} \end{array} \right.$

PZTは振動の節(応力最大点)に入れる